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SOURCE ELLIPTICITY AND THE STATISTICS OF LENSED ARCS

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ABSTRACT

The statistics of gravitationally lensed arcs, which can be used for a variety of cosmological tests, are sensitive to the intrinsic shapes of the source galaxies. I present an analytic formalism that makes it simple to include elliptical sources in analytic calculations of lens statistics. For cuspy lens models, sources with an axis ratio of 2:1 enhance the total number of arcs longer than 10:1 by a factor of order two, while modestly *decreasing* the number ratio of radial arcs to tangential arcs. Source ellipticity is therefore an important systematic effect in detailed quantitative studies, but it should not hinder cosmological applications such as attempts to constrain cluster dark matter profiles with arc statistics.

Subject headings: galaxies: clusters: general — dark matter — gravitational lensing

1. INTRODUCTION

A cluster of galaxies can distort background galaxies into long, thin arcs by gravitational lensing. The statistics of lensed arcs can be used to constrain cluster mass distributions (e.g., Wu & Hammer 1993; Miralda-Escudé 1993a; Bartelmann, Steinmetz & Weiss 1995; Molikawa & Hattori 2000), the population of faint, distant galaxies (e.g., Miralda-Escudé 1993b; Hamana & Futamase 1997; Bézecourt, Pelló & Soucail 1998), and cosmological parameters (e.g., Wu & Mao 1996; Bartelmann et al. 1998). Comparing the number of arcs extended radially relative to the cluster center with the number of arcs stretched tangentially may be an especially good probe of the central density profile in clusters (Molikawa & Hattori 2000; Oguri, Taruya & Suto 2001).

Most calculations of arc statistics assume that the source galaxies are circularly symmetric on the sky. The exception is a series of papers by Bartelmann et al. (1995, 1998; also Meneghetti et al. 2000), which show that elliptical sources increase the likelihood of long, thin arcs but do not carefully quantify the effect. As applications of arc statistics become increasingly detailed, it is important to revisit the question of how elliptical sources affect the statistics of both tangential and radial arcs. In this paper I develop an analytic formalism for including elliptical sources in studies of arc statistics, which makes elliptical sources as easy to work with as circular sources. Section 2 presents the formalism, Section 3 gives examples to quantify the effects of elliptical sources, and Section 4 offers conclusions.

2. ANALYTIC FORMALISM

The lens equation relates the angular position $\mathbf{x}$ of a lensed image to the angular position $\mathbf{u}$ of the intrinsic source,

$$\mathbf{u} = \mathbf{x} - \nabla\phi(\mathbf{x})\,, \tag{1}$$

where ϕ is the projected gravitational potential of the lens, which is related to the projected surface mass density $\Sigma(\mathbf{x})$ via the two-dimensional Poisson equation $\nabla^2\phi(\mathbf{x}) = \Sigma(\mathbf{x})/\Sigma_{cr}$, where Σ_{cr} is the critical surface density for lensing (e.g., Schneider, Ehlers & Falco 1992). The distortions of an image are determined by the magnification tensor

$$\mu = \left[\begin{array}{cc} 1-\phi_{xx} & -\phi_{xy} \\ -\phi_{xy} & 1-\phi_{yy} \end{array}\right]^{-1}, \tag{2}$$

where $\phi_{ij} = \partial^2\phi/\partial x_i \partial x_j$ are second derivatives of the potential.

Consider a source with elliptical symmetry, so it is described by a surface brightness distribution with the form $S(\mathbf{u}) = f(\rho_s)$, where ρ_s is an ellipse coordinate given by

$$\rho_s^2 = \mathbf{u}^t \cdot R^t \cdot \mathcal{Q}_s \cdot R \cdot \mathbf{u}\,, \tag{3}$$

$$\text{where} \quad \mathcal{Q}_s = \begin{bmatrix} 1 & 0 \\ 0 & q_s^2 \end{bmatrix}, \tag{4}$$

$$R = \begin{bmatrix} \cos\theta & \sin\theta \\ -\sin\theta & \cos\theta \end{bmatrix}, \tag{5}$$

where $q_s \geq 1$ is the axis ratio of the source ellipse, θ is the orientation angle of the ellipse, R is a rotation matrix, and t denotes the matrix transpose. Without loss of generality, we can choose coordinates aligned with the eigenvectors of the lensing magnification tensor, so θ is the angle between the source ellipse and the dominant eigenvector of the magnification tensor (the shear vector). In this coordinate system, the magnification tensor can be written as

$$\mu = a \left[\begin{array}{cc} q_l & 0 \\ 0 & 1 \end{array}\right], \tag{6}$$

where $q_l \geq 1$ is the ratio of the magnification eigenvalues; it gives the axis ratio of an image from a circular source, so I refer to it as the lensing axis ratio. Also, a is a scale factor that gives the uniform expansion or contraction of the image relative to the source.

Analytic studies of arc statistics often assume a small source so the shape of the image is easy to calculate, and the assumption appears to be broadly valid (see Hattori, Watanabe & Yamashita 1997). In this limit, the image is an ellipse described by the surface brightness distribution

$I(\mathbf{x}) = S(\mu_{inv} \cdot \mathbf{x}) = f(\rho_i)$, where μ_{inv} is the inverse of the magnification tensor, and ρ_i is an ellipse coordinate given by

$$\begin{aligned} \rho_i^2 &= \mathbf{x}^t \cdot M \cdot \mathbf{x} \,, && (7) \\ \text{where} \quad M &= \mu_{inv}^t \cdot R^t \cdot \mathcal{Q}_s \cdot R \cdot \mu_{inv} \,. && (8) \end{aligned}$$

(Compare eq. 3.) The axis ratio of the observed image, $q_{obs} \geq 1$, is given by the eigenvalues of the tensor M to be

$$q_{obs} = \left[\frac{T + \left(T^2 - 4D\right)^{1/2}}{T - \left(T^2 - 4D\right)^{1/2}} \right]^{1/2} , \qquad (9)$$

$$\begin{aligned} \text{where} \quad T &= q_l^2 + q_s^2 + (q_l^2 - 1)(q_s^2 - 1) \cos^2\theta \,, && (10) \\ D &= q_l^2 \, q_s^2 \,. && (11) \end{aligned}$$

Some simple limits are as follows:

$$q_{obs} = \begin{cases} q_l & \text{if } q_s = 1 \\ q_l \, q_s & \text{if } \theta = 0 \\ \max\left(\frac{q_l}{q_s}, \frac{q_s}{q_l}\right) & \text{if } \theta = \pi/2 \end{cases} \qquad (12)$$

When computing the cross section for arcs, each source position must be weighted by the probability that a source at that position produces a lensed arc. An arc is defined as an image with an axis ratio larger than some threshold, i.e., $q_{obs} \geq Q$ for some value of Q; a popular choice is $Q = 10$ (e.g., Wu & Hammer 1993), although $Q = 4$ may be more relevant for radial arcs (see Oguri et al. 2001). Consider a source with axis ratio q_s and orientation angle θ, at a position such that the lensing axis ratio is q_l. The source produces an arc if

$$\begin{aligned} \cos^2\theta &\geq \xi(Q, q_l, q_s) \,, && (13) \\ \text{where} \quad \xi(Q, q_l, q_s) &= \frac{(Q^2 + 1)\, q_l \, q_s - Q(q_l^2 + q_s^2)}{Q(q_l^2 - 1)(q_s^2 - 1)} \,. && (14) \end{aligned}$$

If the sources have random orientations, the probability of obtaining an arc from a source at that position is then

$$p_{arc}(Q, q_l, q_s) = \begin{cases} (2/\pi) \, \cos^{-1} \sqrt{\xi(Q, q_l, q_s)} & \text{if } 0 \leq \xi \leq 1 \\ 1 & \text{if } \xi < 0 \\ 0 & \text{if } \xi > 1 \end{cases} \qquad (15)$$

Figure 1 shows how to interpret this result. There are three simple regions in the (q_l, q_s) plane. First, for $q_l \geq Q \, q_s$, the lensing distortion is strong enough that any source at that position yields an arc ($p_{arc} = 1$), regardless of the source orientation. Second, for $q_s \geq Q \, q_l$, the sources are intrinsically long enough that any source at that position produces an arc (again $p_{arc} = 1$), although this regime is uninteresting because such elongated sources are rare, and because this case is not really lensing. Third, for $q_l \, q_s < Q$ no source at that position can produce an arc ($p_{arc} = 0$), because neither the intrinsic source shape nor the lensing distortion is large enough (for any orientation).

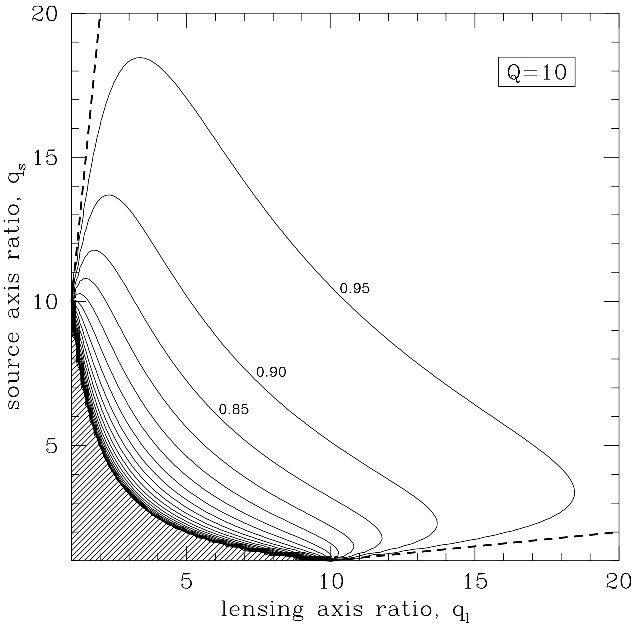

FIG. 1.— The arc probability, p_{arc}, as a function of q_l and q_s, for an arc threshold $Q = 10$. Contours are drawn at $p_{arc} = 0.95, 0.90, 0.85, \ldots$ starting from the upper right, as indicated. The heavy dashed lines indicate $p_{arc} = 1$, while the shaded region in the lower left indicates $p_{arc} = 0$. Source axis ratios larger than $q_s \gtrsim 2$, while implausible, are included to show that p_{arc} is symmetric in q_l and q_s.

The remainder of the (q_l, q_s) plane has intermediate values of p_{arc}, with two interesting qualitative results. First, with elliptical sources there are positions where the lensing distortion is moderate ($q_l < Q$), but some sources can still produce arcs; the arcs are produced when the sources are roughly aligned with the lensing distortion. This result reproduces the result from Bartelmann et al. (1995) that elliptical sources increase the likelihood of long/thin arcs. Second, there are positions where the lensing distortion is strong ($q_l > Q$), but not all sources yield arcs; sources that are approximately orthogonal to the lensing distortion fail to produce arcs.

This analysis makes it simple to include the effects of elliptical sources in calculations of arc statistics. Given sources with a fixed axis ratio q_s, the cross section for arcs with threshold Q is

$$\sigma(Q, q_s) = \int d\mathbf{u} \; p_{arc}\big(Q, q_l(\mathbf{u}), q_s\big) \,, \qquad (16)$$

where $q_l(\mathbf{u})$ is the lensing distortion associated with source position $\mathbf{u}$, and the integral extends over the source plane. While circular sources yield $p_{arc} = 0$ or 1, elliptical sources introduce variable weighting into the integral. Because eqs. (14) and (15) make the effect easy to compute, elliptical sources can be added to calculations of lens statistics with no more work than circular sources. For source positions with multiple images and hence multiple values of p_{arc} (one for each image), the largest value of p_{arc} that corresponds to the desired type of arc (radial or tangential) should be used. The formalism can be extended to a distribution of source shapes. Given a probability distribution $P(q_s)$ for source shapes, the arc cross section is

$$\sigma(Q) = \int d\mathbf{u} \int dq_s \; p_{arc}\big(Q, q_l(\mathbf{u}), q_s\big) \, P(q_s) \,. \qquad (17)$$

For each source position $\mathbf{u}$, the integral over q_s can be computed with fast numerical integration.

3. EXAMPLES

In proposing that arc statistics can be used to constrain the inner profiles of dark matter halos, Molikawa & Hattori (2000) and Oguri et al. (2001) consider only circular sources. I reexamine their proposal to give an example of the quantitative effects of source ellipticity. Following both studies, consider a dark matter halo with a generalized NFW profile,

$$\rho(r) = \frac{\rho_0 r_0^3}{r^\gamma (r_0 + r)^{3-\gamma}} \ , \tag{18}$$

where r_0 is a scale radius and ρ_0 is a characteristic density. The density profile has a central cusp $\rho \propto r^{-\gamma}$; when $\gamma = 1$ it corresponds to the NFW profile (Navarro, Frenk & White 1996, 1997), and when $\gamma = 1.5$ it resembles the steeper cusp advocated by, e.g., Fukushige & Makino (1997), Moore et al. (1998, 1999) and Klypin et al. (2000). It is convenient to define a "concentration" parameter $C = r_{200}/r_*$, where r_{200} is the radius within which the mean density is 200 times the critical density of the universe, often taken to define the edge of halo (e.g., Crone, Evrard & Richstone 1994; Cole & Lacey 1996; Navarro et al. 1996, 1997); and r_* is the radius at which the logarithmic slope of the density is $d(\log \rho)/d(\log r) = -2$. This definition is equivalent to the standard concentration parameter for NFW halos, and it is a good generalization to $\gamma \neq 1$ (see Keeton & Madau 2001). Like Molikawa & Hattori (2000) and Oguri et al. (2001), I consider spherical halos for simplicity, but the formalism presented in Section 2 is fully general.

Lensing depends on the projected surface mass density in units of the critical surface density for lensing. For generalized NFW halos, the lensing strength is determined by the dimensionless parameter

$$\kappa_0 = \frac{\rho_0 r_0}{\Sigma_{cr}} = 10^{4/3}\ \frac{(H^2 GM)^{1/3}}{c^2}\ \frac{D_{ol} D_{ls}}{D_{os}} \tag{19}$$

$$\times\ \frac{(3-\gamma)(r_{200}/r_0)^{\gamma-1}}{{}_2F_1(3-\gamma, 3-\gamma, 4-\gamma, -r_{200}/r_0)} \ ,$$

where M is the halo mass, H is the Hubble parameter evaluated at the lens redshift, and ${}_2F_1(a,b,c,x)$ is the hypergeometric function (e.g., Press et al. 1992). Also, D_{ol}, D_{os}, and D_{ls} are angular diameter distances from the observer to the lens, from the observer to the source, and from the lens to the source, respectively. The complete equations for generalized NFW lenses are given by, e.g., Molikawa & Hattori (2000) and Keeton & Madau (2001).

As a fiducial model, consider a lens of mass $10^{15}\,h^{-1}\,M_\odot$ at redshift $z_l = 0.3$, with sources at redshift $z_s = 1$, in a cosmology with matter density $\Omega_M = 0.3$ and cosmological constant $\Omega_\Lambda = 0.7$. Such halos have a range of concentration parameters with median $C \simeq 4.3$ (e.g., Eke, Navarro & Steinmetz 2000). The lensing strength parameter is then:

$$\kappa_0 = \begin{cases} 0.1776 & \text{if } \gamma = 1.0 \\ 0.0543 & \text{if } \gamma = 1.5 \end{cases} \tag{20}$$

Increasing or decreasing the strength parameter by 0.2 dex corresponds to changes in the halo mass of 0.6 dex (a factor of 4), or to changes in the concentration of about 0.18 dex (the 1σ scatter in the concentration; Bullock et al. 2001).

Figure 2 shows how arc cross sections depend on the source ellipticity $e_s = 1 - b/a$, where a and b are the semimajor and semi-minor axes of the source, respectively. Increasing the source ellipticity increases the cross section for both tangential and radial arcs, but it affects tangential arcs more strongly. From $e_s = 0$ to $e_s = 0.5$ the cross section for tangential arcs increases by a factor of 2.6 for $\gamma = 1.0$ models and 2.3 for $\gamma = 1.5$ models, while the cross section for radial arcs increases by 1.7 for both models. The enhancement factors are not very sensitive to the lensing strength κ_0. They are somewhat more sensitive to assumptions about magnification bias (which is not included in Figure 2), but factors around 2 are still typical.

The statistic advocated by Molikawa & Hattori (2000) is the number ratio of radial and tangential arcs, which is shown in Figure 3. Although both types of arcs are enhanced by elliptical sources, radial arcs are affected less strongly; hence, the ratio of radial to tangential arcs systematically *decreases* with source ellipticity. From $e_s = 0$ to $e_s = 0.5$ the ratio decreases by a factor of about 1.5 for $\gamma = 1.0$ models and 1.4 for $\gamma = 1.5$ models. The dependence on the strength parameter κ_0 is weak (which is why the number ratio is an attractive statistic in the first place). Magnification bias is an important systematic effect in the dependence of the arc number ratio on the cusp slope γ (see Oguri et al. 2001), but it does not dramatically change the dependence on source ellipticity.

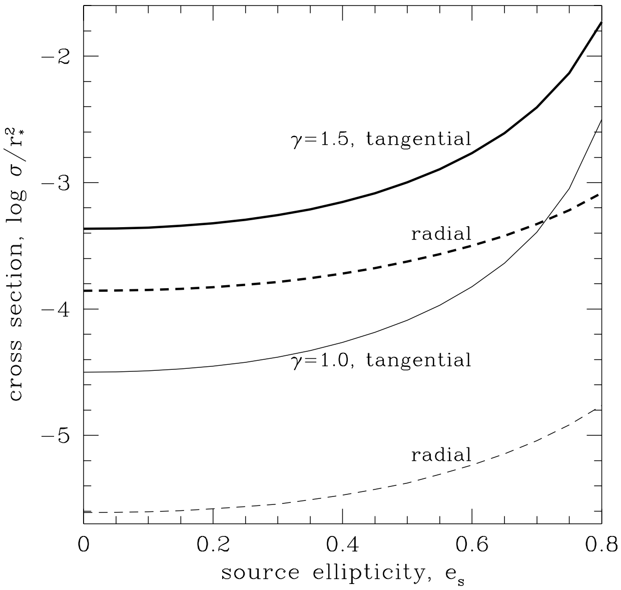

FIG. 2.— Arc cross sections versus source ellipticity, computed for the fiducial model with a length/width threshold $Q = 10$. The light and heavy curves denote models with $\gamma = 1.0$ and $\gamma = 1.5$, respectively. The solid and dashed curves indicate cross sections for tangential and radial arcs, respectively. The cross sections are computed in angular units and are normalized by the radius r_* at which the logarithmic slope of the density is -2.

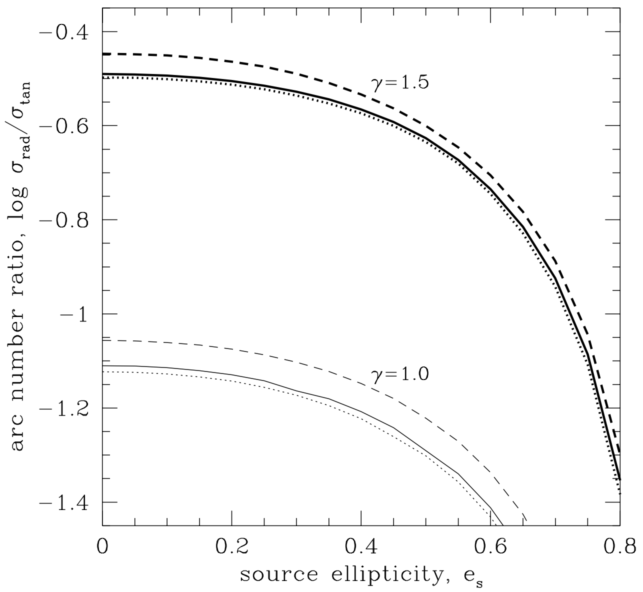

FIG. 3.— The number ratio of radial and tangential arcs as a function of the source ellipticity, computed with a length/width threshold $Q = 10$. The light and heavy curves denote models with $\gamma = 1.0$ and $\gamma = 1.5$, respectively. The solid curves indicate the fiducial model, while the dashed (dotted) curves indicate models where the lensing strength is increased (decreased) by 0.2 dex.

For modest source ellipticities, $e_s \lesssim 0.5$, the change in the arc number ratio due to source ellipticity is substantially smaller than the difference between $\gamma = 1.0$ and $\gamma = 1.5$ models. Hence, even if the source shape distribution is poorly known, it should still be possible for arc statistics to distinguish between models with different density cusps. Source ellipticity is thus an important systematic effect that must be included to obtain robust quantitative results, but it is weaker than effects that one may wish to probe with arc statistics.

These examples are based on axially symmetric lens models, as were the studies by Molikawa & Hattori (2000) and Oguri et al. (2001). Departures from axial symmetry, such as an aspherical cluster potential or subclumps in the cluster mass distribution, can affect the number of arcs by an order of magnitude or more (Bartelmann et al. 1995). While asymmetry in the lens thus appears to be more important than non-circular sources, the quantitative effects of lens asymmetry on the arc number ratio, and the combined effects of lens and source asymmetry, are under investigation (M. Meneghetti et al., in preparation).

4. CONCLUSIONS

I have presented a simple formalism for including the effects of elliptical sources in analytic calculations of the statistics of lensed arcs. It is straightforward to compute, as a function of source position, the probability that a source with a given axis ratio and a random orientation yields a lensed arc. This probability serves as a weighting factor in the integral over source positions to determine the lensing cross section. The formalism is fully analytic, so elliptical sources require no more work than circular sources; and it is easily extended to a distribution of source shapes.

In generalized NFW lenses, elliptical sources enhance the likelihood of producing both tangential and radial arcs; sources with ellipticity $e_s = 0.5$ increase the expected number of arcs by about a factor of two (relative to circular sources). Radial and tangential arcs are affected differently, so the number ratio of radial arcs to tangential arcs decreases as e_s increases; from $e_s = 0$ to $e_s = 0.5$ the ratio drops by a factor of about 1.5. This change is an important systematic effect in quantitative studies of arc statistics, but by itself it should not significantly limit attempts to constrain the dark matter profile of clusters. These conclusions are drawn from examples with spherical lenses, and it will be interesting to see whether elliptical sources have any different effects when the lenses are non-spherical (M. Meneghetti et al., in preparation).

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